

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Luetzen et al.	Docket No.:	QIM 2004 SP 00115 US
Serial No.:	10/721,225	Art Unit:	1792
Filed:	November 26, 2003	Examiner:	Tran, Binh X.
		Conf. No.:	5694
For:	Method and Structures for Increasing the Structure Density and the Storage Capacitance in a Semiconductor Wafer		

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Dear Sir:

The following amendments and remarks are presented in response to the Examiner's Office Action mailed July 30, 2009. Please amend the above-referenced application as follows.